

IDS Filed 1/20/04

PTO-1449 Information Disclosure Citation in an Application	Application No. 10/760,443	Applicant(s) Eoff, et al.	
	Docket Number 2001-IP-005267U1P1	Group Art Unit 1712	Filing Date 1/20/2004

U.S. PATENT DOCUMENTS

		DOCUMENT NO.	ISSUE/ PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
JF	1	2,863,832	12/09/58	Perrine	507	267	05/14/54
	2	2,910,436	10/27/59	Alhambra, et al.	166	307	10/02/53
	3	3,215,199	11/02/65	Dilgren	166	250.01	02/21/63
	4	3,297,090	01/10/67	Dilgren	166	300	04/24/64
	5	3,441,085	04/29/69	Gidley	166	307	09/07/67
	6	4,532,052	07/30/85	Weaver, et al.	252	8.55	08/25/82
	7	5,944,106	08/31/99	Dalrymple, et al.	166	281	08/06/97
	8	5,972,848	10/26/99	Audibert, et al.	507	119	10/15/96
	9	6,070,664	06/06/00	Dalrymple, et al.	166	281	02/12/98
	10	6,476,169	11/05/02	Eoff, et al.	523	307.2	09/28/00
	11	6,476,283	11/05/02	Devore, et al.	585	250	06/29/00
	12	6,497,283	12/24/02	Eoff, et al.	166	293	11/19/01
	13	6,569,983	05/27/03	Treybig, et al.	528	102	12/20/01
✓	14	10/236,722		Eoff, et al.			09/06/02
JF	15	10/375,787		Eoff, et al.			02/27/03

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							Yes	No
JF	16	WO 02/097236	12/05/02	PCT	E21B	43/02	X	

NON-PATENT DOCUMENTS

		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	

EXAMINER	/John Figueroa/	DATE CONSIDERED	09/29/2006
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	101760,443	Eoff, et al.	
Information Disclosure Citation in an Application	Docket Number	Group Art Unit	Filing Date
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U.S. PATENT DOCUMENTS

		DOCUMENT NO.	ISSUE/ PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
JF	17	3,307,630	03/07/67	Dilgren, et al	166	38	06/12/64
JF	18	3,251,415	05/17/66	Bombardier, et al	166	42	04/01/65
JF	19	6,364,016	04/02/02	Dalrymple, et al	166	270	10/26/00
JF	20	5,271,466	12/21/93	Harms	166	300	10/30/92
JF	21	5,735,349	04/07/98	Dawson, et al	166	295	08/16/96
JF	22	6,228,812	05/08/01	Dawson, et al	507	221	04/05/99
JF	23	6,283,210	09/04/01	Soliman, et al	166	270	09/01/99

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							Yes	No

NON-PATENT DOCUMENTS

		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					
JF	24	INIKORI, SOLOMON OVUEFERAYE, "Numerical Study of Water Coning Control with Downhole Water Sink (DWS) Well Completions in Vertical and Horizontal Wells," A Dissertation, August 2002, title page, contents, abstract and pp. 17-18, The Department of Petroleum Engineering					
JF	25	HALLIBURTON, 2001 Press Release, "First Halliburton H2Zero™ Conformance Solution Job Performed for a Producing Well in Egypt," www.halliburton.com/news/archives/2001esgnws_111901.jsp , November 19, 2001, 2 pp.					
JF	26	HALLIBURTON, 2001 Press Release, "Halliburton Performs First H2Zero™ Conformance Solution Job in North America," www.halliburton.com/news/archives/2001esgnws_082201.jsp , August 22, 2001, 2 pp.					
JF	27	HALLIBURTON, 2001 Press Release, "Halliburton Technology Uses Revolutionary Polymer system to Control Unwanted Water Production," www.halliburton.com/news/archives/2001esgnws_053101.jsp , May 31, 2001 2 pp.					
JF	28	BJ SERVICES COMPANY, Aquacon, 08/01/01, 2 pp.					
JF	29	BJ SERVICES COMPANY, Aquatrol 1, 12/14/00, 2 pp.					
JF	30	EOFF, LARRY ET AL., "Structure and Process Optimization for the Use of a Polymeric Relative-Permeability Modifier in Conformance Control," SPE eLibrary paper no. 64985, 2001 Copyright, 2 pp.					
JF	31	BOTERMANS, C. WOUTER ET AL. "Relative Permeability Modifiers: Myth or Reality?" SPE eLibrary paper no. 68973, 2001 copyright, 2 pp.					
JF	32	BJ SERVICES COMPANY, Aquacon, 08/01/01, 2 pp.					

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	Docket Number 2001-IP-005267U1P1	Group Art Unit 1712	Filing Date 01/20/2004

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
JF1.	4,152,274	05/01/79	Phillips, et al.	876	296	02/09/78
JF2.	4,552,670	11/12/85	Lipowski, et al.	704	553	02/22/85
JF3.	6,627,719	09/30/03	Whipple, et al.	774	325	01/31/01
JF4.	6,855,672	02/15/05	Poelker	507	225	11/07/01
JF5.	US 2003/0104948 US Pat. App. Ser. No. 11/183,028)	06/05/03	Poelker, et al.	507	100	11/07/01
JF6.	US 2004/0171495	09/02/04	Zamora, et al.	507	100	02/27/03

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